Special Issue

Process Control and Smart Manufacturing for Industry 4.0

Message from the Guest Editor

This Special Issue "Process Control and Smart Manufacturing for Industry 4.0" is focused on extended papers on the following topics:

- Process Automation
- Process Control and Monitoring
- Design Principles in Industry 4.0
- Smart Manufacturing and Technologies
- Smart Factories
- Machine Learning and Artificial Intelligence in Manufacturing
- Chemical Process Control

Submissions on other topics are also welcome provided they fit within the theme of the Special Issue.

Guest Editor

Prof. Dr. Sergey Y. Yurish International Frequency Sensor Association (IFSA), 08860 Castelldefels, Barcelona, Spain

Deadline for manuscript submissions

closed (1 December 2021)



Processes

an Open Access Journal by MDPI

Impact Factor 2.8 CiteScore 5.5



mdpi.com/si/66504

Processes Editorial Office MDPI, Grosspeteranlage 5 4052 Basel, Switzerland Tel: +41 61 683 77 34 processes@mdpi.com

mdpi.com/journal/

processes





Processes

an Open Access Journal by MDPI

Impact Factor 2.8 CiteScore 5.5



processes



About the Journal

Message from the Editor-in-Chief

You are invited to contribute either a research article or a comprehensive review for consideration and publication in *Processes* (ISSN 2227-9717). *Processes* is published in open access format – research articles, reviews, and other content are released on the internet immediately after acceptance. The scientific community and the general public have unlimited, free access to the content. As an open access journal, *Processes* is supported by the authors and their institutes through the payment of article processing charges (APCs) for accepted papers. We would be pleased to welcome you as one of our authors.

Editor-in-Chief

Prof. Dr. Giancarlo Cravotto

Department of Drug Science and Technology, University of Turin, Via P. Giuria 9, 10125 Turin, Italy

Author Benefits

Open Access:

free for readers, with article processing charges (APC) paid by authors or their institutions.

High Visibility:

indexed within Scopus, SCIE (Web of Science), Ei Compendex, Inspec, AGRIS, and other databases.

Journal Rank: CiteScore - Q2 (Chemical Engineering (miscellaneous))